

## *To L2 License Students (Sickness absences)*

This is to inform you that an EE262 (Electromagnetic Field Theory) make-up control exam will be scheduled for those who had justified their absence during the control exam. It will take place at the same time as *Replacement Final Exam*. The date and place will be communicated to you by the administration of the institute.

**Teacher: K. DJAFRI**